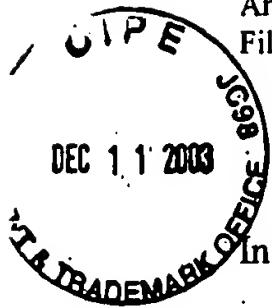


Appln. No.: 09/783,023
Amendment dated December 11, 2003
Filed with Appeal Brief



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Yoshiaki FUKUZUMI et al.

Serial No.: 09/783,023

Filed: February 15, 2001

For: SEMICONDUCTOR DEVICE USING
FUSE/ANTI-FUSE SYSTEM AND METHOD
OF MANUFACTURING THE SAME

Atty. Docket No.: 001701.00059

Group Art Unit: 2823

Examiner: G. Fourson, III

Confirmation No.: 6061

AMENDMENT AFTER FINAL REJECTION

MAIL STOP AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

To place the application in better form for appeal, please amend the instant application as follows:

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the Listing of Claims, which begins on page 3 of this paper.

Remarks/Arguments begin on page 5 of this paper.